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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Visokay et al.	Docket No.:	TI-35227
Serial No.:	10/734,708	Art Unit:	2813
Filing Date:	12/11/2003	Examiner:	Thanhha S. Pham
Customer No.:	23494	Conf. No.:	2373

Title: Method for Fabricating Transistor Gate Structures and Gate Dielectrics Thereof

CERTIFICATION OF FACSIMILE TRANSMISSION

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NAME OF INVENTOR(S):	
Visokay et al	
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Method for Fabricating . . .	
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